**∤\ 00862.022199.



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
V.''' EMOTO	:	Examiner: P. L. Rodriguez
Keiji EMOTO) :	Group Art Unit: 2125
Application No.: 09/833,766)	
	:	Confirmation No.: 4154
Filed: April 13, 2001)	RECEIVED
For: PIPE STRUCTURE, ALIGNMENT APPARATUS,)	
ELECTRON BEAM LITHOGRAPHY APPARATUS,	:	SEP 2 2 2004
EXPOSURE APPARATUS, EXPOSURE APPARATUS)	Technology Center 2100
MAINTENANCE METHOD, SEMICONDUCTOR DEVICE	:	1001111011033
MANUFACTURING METHOD, AND SEMICONDUCTOR)	G 1 . 20 2004
MANUFACTURING FACTORY	:	September 20, 2004

Mail Stop Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

X No additional fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED							
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRES	ENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	10	MINUS	27	=	0	x \$9 \$18	\$0.00
INDEP. CLAIMS	2	MINUS	11	=	0	x \$43 \$86	\$0.00
Fee for Mult	Fee for Multiple Dependent claims \$145/\$290						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT							\$0.00

	°Verified Statement claiming small entity status is enclosed, if not filed previously.
	A check in the amount of \$ is enclosed including the additional claims fee.
	Charge \$ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.
X	Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.
	A check in the amount of \$ to cover the fee for a two month extension is enclosed.
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.
X	Applicant's attorney, Steven E. Warner, may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.
	Respectfully submitted,

Attorney for Applicant
Jack S. Cubert

Registration No. 24,245

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3800 Facsimile: (212) 218-2200

SEW/JSC/dc

DC_MAIN 178486v1



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METHOD, SEMICONDUCTOR DEVICE)	SEP 2 2 2004
MANUFACTURING METHOD, AND SEMI-	:	
CONDUCTOR MANUFACTURING FACTORY)	Technology Center 2100

Mail Stop Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated June 21, 2004, please amend the above identified application as follows: